

## PATENT ASSIGNMENT

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CONVEYING PARTY DATA	
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RECEIVING PARTY DATA	
Name:	National Institutes of Health (NIH), U.S. Dept. of Health and Human Services (DHHS), U.S. Government
Street Address:	NIH Division of Extramural Inventions and Technology Resources (DEITR)
Internal Address:	6705 Rockledge Drive, Suite 310, MSC 7980
City:	Bethesda
State/Country:	MARYLAND
Postal Code:	20892-7980
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	09280377
CORRESPONDENCE DATA	
Fax Number:	3014800272
<i>Correspondence will be sent via US Mail when the fax attempt is unsuccessful.</i>	
Email:	edison@nih.gov
Correspondent Name:	Director, DEITR
Address Line 1:	NIH, 6705 Rockledge Drive, Suite 310
Address Line 2:	MSC 7980
Address Line 4:	Bethesda, MARYLAND 20892-7980
NAME OF SUBMITTER:	Director, DEITR, NIH
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Invention Title: Method for the Growth of Teflon-Like Films Using Thermal CVD

Inventor(s): David J Edell, Edward F Gleason, Karen K Gleason, Scott Limb, Herbert H Sawin

U.S. Filing/Issue Date: 03/29/1999

Patent or Application Serial No.: 09/280,377

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Foreign Applications filed/intended in (countries): \_\_\_\_\_

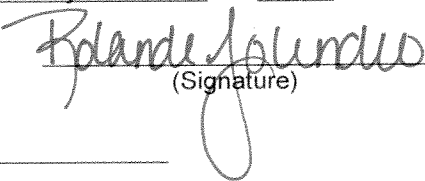
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Signed this 30th day of January, 20 13.

By Rolande Johndro  
(Institutional Business Official)

  
(Signature)

Title Patent Compliance Administrator

For MASSACHUSETTS INSTITUTE OF TECHNOLOGY  
(Grantee/Contractor Organization)

At MIT Technology Licensing Office NE18-501 One Cambridge Center, Kendall Square

Cambridge, MA 02142 US  
(Business Address)